



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of ) Art Unit: 2828  
Koichiro TANAKA ) Examiner: A. Rodriguez  
Serial No. 09/481,396 )  
Filed: January 12, 2000 )  
For: LASER IRRADIATION )  
APPARATUS )  
)

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**AMENDMENT**

Honorable Commissioner of Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated September 25, 2002 please amend the  
above-identified application as follows:

**IN THE CLAIMS:**

Please amend claims 1-7, 10 and 13-14 as follows:

1. (Amended) A laser irradiation apparatus comprising:  
a beam generating unit for emitting a laser beam;  
a cylindrical lens group for dividing the emitted laser beam in a first direction,  
said cylindrical lens group comprising a plurality of cylindrical lenses queuing in said first  
direction, each of the cylindrical lenses extending in a second direction which is vertical  
to said first direction;  
an optical system for overlapping divided laser beams; and  
a slit located between said beam generating unit and said cylindrical lens  
group, for making edges of the emitted laser beam straight lines extending parallel to  
said second direction of each cylindrical lens.

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